Attorney's Docket No. 5576-125

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of Kubota et al.

Serial No.: To be Assigned Filed: Concurrently Herewith

For: RESIST MATERIAL AND METHOD

FOR PATTERN FORMATION

Date: May 8, 2001

BOX PATENT APPLICATION Commissioner for Patents Washington, DC 20231

PRELIMINARY AMENDMENT

Sir:

Prior to the examination of the above application, please amend the above-identified application as follows. Attached hereto is a marked up version of the changes made to the claims by the current amendment. The marked up version of the changes to the claims is captioned "Version With Markings To Show Changes Made".

In the Specification:

Please insert the following text on page 1, line 1:

- Cross-Reference to Related Applications

The present application claims priority to Japanese Patent Application No. 2000-139537 filed May 12, 2000, the disclosure of which is incorporated herein by reference in its entirety.

In the Claims:

Please delete Claims 5-8 for the purposes of rewriting.

Please insert the following new claims.

9. A resist material according to claim 1 wherein said or more surfactants having a fluorine substituent is selected from the group consisting of perfluoroalkylpolyoxyethylene ethanol, fluorinated alkyl ester,



